

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Francisco ARIAS et al.

Examiner: Mathieu D. VARGOT

Serial No.: 10/727,124

Group Art Unit: 1732

Filing Date: December 3, 2003

Confirmation No: 4751

Title: METHOD OF MANUFACTURING MICRONEEDLE STRUCTURES USING SOFT LITHOGRAPHY AND PHOTOLITHOGRAPHY

**AMENDMENT UNDER 37 CFR § 1.111
AND REQUEST FOR EXTENSION OF TIME**

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action mailed from the PTO on October 1, 2007. A two-month extension of time is requested. The fee for the extension accompanies this response. Please amend the application as indicated herein.

The *Listing of the Claims* begins on page 2 of this document. Claim 10 is cancelled. Claim 1 is amended. Claims 22-26 are new.

Remarks begin on page 7 of this document.